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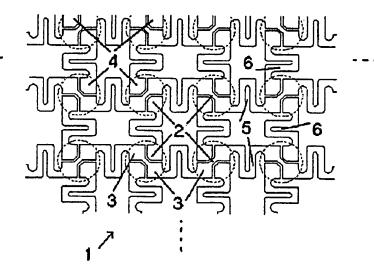
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(72) Inventor; and

(75) Inventor/Applicant (for US only): HOLMAN, Albert, ning of each regular issue of the PCT Gazette.

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the begin-

(54) Title: SENSOR MAT FOR REGISTERING A PRESSURE PROFILE



(57) Abstract: The invention relates to a sensor mat for registering a pressure profile, comprising sensor elements distributed over the mat wherein each sensor element has a first and a second electrode, which two electrodes interact with a resistive layer, such that a pressure load changes the electrical resistance between the two electrodes relative to the resistance at zero load, wherein the sensor elements are provided on a flexible carrier in the form of a matrix and wherein the sensor elements that are placed in the same row or in the same column always share one row electrode or column electrode, respectively. Each row electrode and/or column electrode between the sensor elements has a meandering path.

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Sensor mat for registering a pressure profile

The invention relates to a sensor mat for registering a pressure profile, comprising sensor elements distributed over the mat, wherein each sensor element has a first and a second electrode, which two electrodes interact with a resistive layer such that a pressure load changes the electrical resistance between the two electrodes relative to the resistance at zero load, wherein the sensor elements are provided on a flexible carrier in the form of a matrix and wherein the sensor elements that are placed in the same row or in the same column always share one row electrode or column electrode, respectively.

Such a sensor mat is known, for example, from US-A-4,734,034. The known sensor mat has a top layer and a bottom layer in which electrodes are arranged in rows or columns, respectively. Between the top layer and the bottom layer there is a separating layer. Further, the electrodes of top layer and bottom layer are provided with a resistive coating. When applying a load to the mat it is possible to determine with the aid of the electrodes where on the mat the pressure load changes the resistance between the electrodes. The known sensor mat is especially suitable for determining the pressure profile of teeth placed on both sides of the mat.

The object of the invention is to provide a sensor

25 mat that is suitable for registering pressure profiles from
persons and/or objects in chairs, beds or in connection with
the use of medical aids. The sensor mat has to meet special
requirements, for example, when the sensor mat does not have
a solid supporting surface. A particular requirement with the

30 applications mentioned is that the sensor mat must be able to
tolerate a double bend without detracting from the accuracy
of the determination, or causing folds in the carrier or a
break in one or several of the row electrodes and/or column
electrodes.

In accordance with the invention this requirement is met by embodying the sensor mat such that each row electrode

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and/or column electrode between the sensor elements has a
meandering path. When the flexible carrier on which the
sensor elements are provided bends in two directions, the
meandering portions of the electrodes will be able to move
outside the plane of the carrier while actually staying
intact but nevertheless allowing the sensor elements to move
in relation to one another. The measure in which a double
bend is tolerated may then be chosen by suitably adjusting
the form and dimensions of the meandering portions of the
electrodes.

In another aspect of the invention it is desirable for the electrodes of the sensor elements to be provided on the carrier on top of each other, separated from each other by an insulating layer. This is a reliable manner of manufacturing a very thin sensor mat.

It is further desirable for the resistive layer of the sensor elements to be provided on the electrodes, with both electrodes on the same side of the resistive layer.

In a further aspect of the invention it is advanta20 geous for the resistive layer to be attached to the electrode
layer by means of a layer of adhesive , and that the layer of
adhesive comprises aeration holes. Such aeration holes
promote the contact of the resistive layer with the two
electrodes when a load is applied on the sensor elements.

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The effectiveness of the sensor elements of the sensor mat may be assisted by providing each sensor element separately with a support surface. This support surface at the position of the sensor elements and between the meandering portions of the electrodes helps the electrodes at that position to be kept flat.

With reference to the drawing of a single figure the invention will be further elucidated below.

The figure shows a schematic top view of a portion of a sensor mat according to the invention. This sensor mat 1 comprises sensor elements 2 evenly distributed over the mat 1, each sensor element 2 having a first electrode 3 and a second electrode 4. The two electrodes 3 and 4 interact with a resistive layer provided on top of the two electrodes, such

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that relative to the resistance at zero load, the application of a pressure load changes the electrical resistance between the two electrodes 3 and 4. As a rule one thing and another is designed such that a pressure load will produce a reduced 5 resistance between the first electrode 3 and the second electrode 4.

The figure shows in an illustrative manner that the sensor elements 2 are arranged in matrix form. These sensor elements 2 which as mentioned above comprise a first elec-10 trode 3, a second electrode 4, and (not shown) a resistive layer provided on these two electrodes, are provided on a flexible carrier. This may, for example, be a polyester film or a carrier made from another suitable material. The figure further clearly shows that the sensor elements 2 that are 15 arranged in the same row or in the same column always share one row electrode or column electrode; see, for example, the row electrode 5 connecting a number of first electrodes 3 and the column electrode 6 connecting a number of second electrodes 4.

The figure also clearly illustrates that each row electrode 5 and/or column electrode 6 has a meandering path between the sensor elements 2.

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It can further be observed that the various electrodes 3 and 4 of the sensor elements 2 are arranged on top 25 of each other on the carrier while being separated from each other by an insulating layer so as to avoid short circuiting. This is not (or not clearly) shown in the figure but is completely known to the person skilled in the art so that there is no need for further explanation.

It is further remarkable that the resistive layer of the sensor elements 2 are provided on the electrodes 3, 4 with both electrodes together being located at the same side of the resistive layer. To conveniently accomplish this, the resistive layer is attached to the electrode layer 3, 4 by 35 means of a layer of adhesive , with aeration holes in the layer of adhesive . These aeration holes make it possible to press the resistive layer on to the various electrodes 3, 4 of the sensor elements 2, so as to make sensitive determinaWO 03/052368 PCT/NL02/00816

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tion possible of the change in resistance caused by the pressure load between these electrodes 3, 4.

Finally, it is desirable for each sensor element 2 separately to be provided with a relatively rigid support 5 surface to aid the measuring of the pressure load on the respective sensor elements. This also is quite clear to the person skilled in the art, so that further explanation is not necessary.

CLAIMS

- 1. A sensor mat (1) for registering a pressure profile, comprising sensor elements (2) distributed over the mat (1) wherein each sensor element (2) has a first (3) and a

 5 second electrode (4), which two electrodes interact with a resistive layer, such that a pressure load changes the electrical resistance between the two electrodes relative to the resistance at zero load, wherein the sensor elements (2) are provided on a flexible carrier in the form of a matrix and

 10 wherein the sensor elements (2) that are placed in the same row or in the same column always share one row electrode (5) or column electrode (6), respectively characterised in that each row electrode (5) and/or column electrode (6) between the sensor elements (2) has a meandering path.
- 2. A sensor mat according to claim 1, characterised in that the electrodes (3, 4) of the sensor elements (2) are provided on the carrier on top of each other, separated from each other by an insulating layer.
- 3. A sensor mat according to claim 1 or 2, charac20 terised in that the resistive layer of the sensor elements
 (2) is provided on the electrodes (3, 4), with both electrodes (3, 4) on the same side of the resistive layer.
- 4. A sensor mat according to claim 1 or 2, characterised in that the resistive layer is attached to the electrode layer (3, 4) by means of a layer of adhesive, and that the layer of adhesive comprises aeration holes.
 - 5. A sensor mat according to one of the preceding claims, characterised in that each sensor element (2) separately is provided with a support surface.

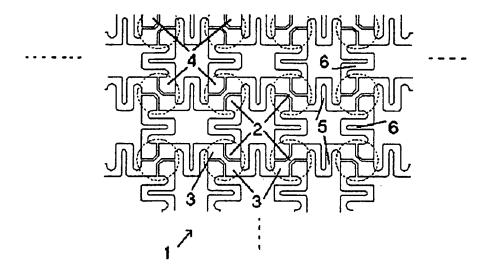


Fig. 1

INTERNATIONAL SEARCH REPORT

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A. CLASSIFICATION OF SUBJECT MATTER IPC 7 G01L1/20									
According to International Patent Classification (IPC) or to both national classification and IPC									
B. FIELDS SEARCHED									
Minimum documentation searched (classification system followed by classification symbols) IPC 7 G01L									
Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched									
Electronic data base consulted during the international search (name of data base and, where practical, search terms used) EPO-Internal, WPI Data, PAJ									
C. DOCUMENTS CONSIDERED TO BE RELEVANT									
Category •	Citation of document, with Indication, where appropriate, of the re		Relevant to claim No.						
X	WO 00 16053 A (I.E.E. INTERNATION ELECTRONICS & ENGINEERING S.A.R. 123 March 2000 (2000-03-23) abstract; figures		1-3,5						
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Α	DE 42 37 072 C (MERCEDES-BENZ AKTIENGESELLSCHAFT E.A.) 2 December 1993 (1993-12-02) the whole document 			1-5					
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